

IFD

In re the Application of: Yoshimasa NAGAKURA et al.

Group Art Unit: 2813

Serial Number: 10/705,881

Examiner: Laura M. Schillinger

Filed: November 13, 2003

Confirmation Number: 6093

For: METHOD FOR FABRICATING A SEMICONDUCTOR DEVICE

Attorney Docket Number:

032105

Customer Number:

38834

PETITION FOR EXTENSION OF TIME

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450 January 25, 2006

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated September 30, 2005 for 1 month from December 30, 2005 to January 30, 2006.

Attached please find a check in the amount of \$120.00 for the cost of the extension. If any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

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